In application of:)
Sheppard et al.) Before the Examiner: Ling Siu Choi
Serial No.: 09/858,313)
Filed: May 15, 2001) Group Art Unit: 1713)
For: Use of Vapor-Deposited Conform	•

RESPONSE TO OFFICE ACTION MAILED JULY 1, 2004

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Responsive to the Office Action, mailed July 1, 2001, Applicants respectfully request reconsideration of the above-identified application in view of the following remarks.

Status of the claims.

The Examiner indicated that claims 1-5 are pending at the issuance of this Office Action.